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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Zhu et al.

Docket Number: TI-36284

Serial No.: 10/772,709

Art Unit: 2814

Filed: February 5, 2004

Examiner: Phat X Cao

For: HIGH DENSITY VERTICALLY STACKED SEMICONDUCTOR DEVICE

CERTIFICATION OF FACSIMILE TRANSMISSION

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FACSIMILE COVER SHEET

FAXED: 07/18/2005 DUE: 07/24/2005 ATTY/SECY: YT/jsm		
Zhu et al. TITLE OF INVENTION: Hish Density Vertically Stacked TIFILE NO.: DEPOSIT ACCT. NO.: T1-36284 20-0668		Serial No.: 10/772,709 Conf. No: 5626
X FACSIMILE COVER SHEET NEW APPLICATION DECLARATION (# Pages) ASSIGNMENT (# Pages) FORMAL DRAWINGS INFORMAL DRAWINGS CONTINUATION APP'N (# Pages)		AMENDMENT (pages) EOT (# Page) NOTICE OF APPEAL (Page) APPEAL (# Pages) ISSUE FEE (#Pages) REPLY BRIEF (IN TRIPLICATE) (# Pages) X ELECTION (1 pg)

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE PATENT APPLICATION

JUL 1 8 2005

Appl. No.

10/772,709

Confirmation No. 5626

Applicant Filed

Jianbai Zhu et al. February 5, 2004

TC/A.U.

2814

Examiner

Phat X Cao

Docket No.

TI-36284

Customer No.

23494

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

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ELECTION

Sir:

In response to the Examiner's restriction requirement mailed June 24, 2005, applicants elect Group I, claims 1-15, for prosecution purposes.

Texas Instruments Incorporated P. O. Box 655474, M/S 3999 Dallas, Texas 75265 (972) 917-5355

Respectfully submitted.

mey for Applicants

g. No. 52,305